

I hereby certify that this correspondence for Application Serial
10/613,620 is being sent electronically via EFS-WEB
transmission to Technology Center 1762: Examiner Bret P.
Chen, Facsimile Number: (571) 273-8300 on March 26, 2007.

/Kevin E. Kuehn/

Kevin E. Kuehn, Reg. No. 51,904

March 26, 2007

Date

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: David C. Fairbourn
Serial No: 10/613,620
Filing Date: July 3, 2003
Art Unit: 1762
Examiner: Bret P. Chen
Title: SIMPLE CHEMICAL VAPOR DEPOSITION SYSTEM AND
METHODS FOR DEPOSITING MULTIPLE-METAL ALUMINIDE
COATINGS
Confirmation No.: 4378
Attorney Docket: MTCL-09

Cincinnati, Ohio 45202

March 26, 2007

Mail Stop Amendment
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL AMENDMENT UNDER 37 CFR § 1.111

Sir:

In follow-up to the Amendment Under 37 CFR § 1.111 filed on January 12, 2007,
please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks begin on page 12 of this paper.